



**ELECTRONIC COPY**

LG649422834  
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August 29, 2024

IGI Report Number **LG649422834**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.78 X 5.89 X 3.91 MM**

**GRADING RESULTS**

Carat Weight **2.14 CARATS**

Color Grade **G**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

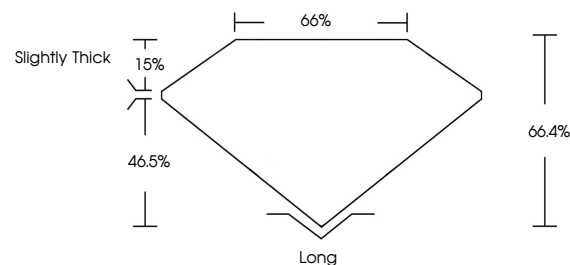
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG649422834**

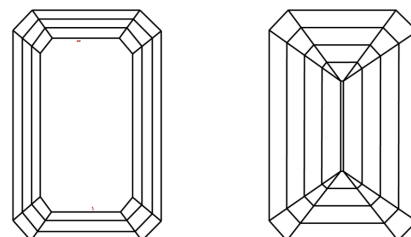
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

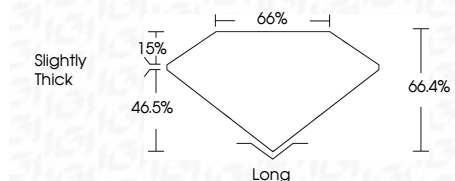
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No **LG649422834**  
**EMERALD CUT**

**2.14 CARATS**  
Carat Weight **G**  
Color Grade **VVS 2**  
Depth **66.4%**  
Table **65%**  
Girdle **Slightly Thick**

**Long**  
Culet **EXCELLENT**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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